



Inventor: Shozo Nagano et al.

Title: Physical Vapor Deposition Targets

Assignee: Honeywell International Inc.

#20

INFORMATION DISCLOSURE STATEMENT

References – See Attached Form PTO-1449

The attached form PTO-1449 is submitted in compliance with 37 CFR §1.56. No admission is made regarding whether any of the submitted references is prior art. Copies of the references are attached.

Respectfully submitted,

Dated:

April 4, 2003

Attorney:

Jennifer J. Taylor
Jennifer J. Taylor, Ph.D.
Reg. No. 48,711